

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TOSHIMA, *et al.*

Serial No.: 10/052,534

Filed: January 23, 2002

For: SUBSTRATE PROCESSING APPARATUS AND
SUBSTRATE PROCESSING METHOD



Art Unit: 1746

Examiner: Kornakov, Michail

Atty. Dckt: 033082M115

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop: Amendment

Dear Sir:

This is in response to the Office action mailed November 1, 2005, to which the time for response was set to expire February 1, 2006. A Petition for a Three-Month Extension of Time and the requisite fee are submitted herewith to extend the due date to May 1, 2006. Claims 1-34 were pending. Claims 10-34 were withdrawn from consideration and claims 1-9 are rejected. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper.
Remarks begin on page 8 of this paper.

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